

- 45. (New) A polishing apparatus according to claim 44, wherein said transferring device includes a shock absorber for resiliently supporting said holder so that the workpiece is not subject to impact force during the transfer between said transferring device and said top ring.
- 46. (New) A polishing apparatus according to claim 44, wherein said holder comprises a support member having a suction hole connected to a vacuum source for attracting the workpiece to said support member.
- 47. (New) A polishing apparatus according to claim 44, further comprising a washing unit for washing the workpiece after it is received by said transferring device.
- 48. (New) A polishing apparatus according to claim 44, wherein said holder has a pad to support the workpiece thereon.

<u>REMARKS</u>

In the Office Action, the Examiner noted that the original patent, or a declaration as to its loss, must be received before the reissue application can be allowed; pointed out alleged defects in the reissue declaration, and rejected claims 1-43 as being based upon a defective reissue declaration. The Examiner also

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